



INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Complete If Known			
		Application Number	10/802,667		
		Filing Date	March 16, 2004		
		First Named Inventor	Xie, Jun		
		Art Unit	To Be Assigned		
		Examiner Name	To Be Assigned		
Sheet	1	of	1	Attorney Docket Number	020859-002710US

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
PN	0001	J. Xie, J. Shih, Y.C. Tai. (2003). "Integrated Surface-Micromachined Mass Flow Controller." 16th IEEE International Conference on Micro Electro Mechanical Systems (MEMS '03). pg. 20-23.	
	0002	J. Xie, Q. He, Y.C. Tai, J. Liu, T. Lee. (2003). "Electrolysis-Based On-Chip Dispensing System for ESI-MS." 16th IEEE International Conference on Micro Electro Mechanical Systems (MEMS '03). pg. 443-448.	
	0003	J. Xie, X. Yang, X.Q. Wang, Y.C. Tai. (2001). "Surface Micromachined Leakage Proof Parylene Check Valve." 14th IEEE International Conference on Micro Electro Mechanical Systems (MEMS '01). pg. 539-542.	
	0004	K. Shida, A.B.M. Ismail. (1999). "Measurement of Concentration of Electrolytic Solution Based on Novel Non-Contact Multi-Sensing Techniques." IEEE Instrumentation and Measurement Technology Conference, (IMTC'99). pg. 1372-1376.	
	0005	R.E. Oosterbroek, T.S.J. Lammerink, J.W. Berenschot, A. van den Berg, Elwenspoek. (1997). "Designing, Realization And Characterization Of A Novel Capacitive Pressure/Flow Sensor." International Conference on Solid-State Sensors and Actuators (Transducers '97). pg.151-154.	
	0006	S. Wu, J. Mai, Y. Zohar, Y.C. Tai, C.M. Ho. (1998). "A Suspended microchannel with Integrated Temperature Sensors for High-Pressure Flow Studies." 11th IEEE International Workshop on Micro Electro Mechanical Systems (MEMS '98). pg. 87-92.	
	0007	T.J. Yao, X. Yang, Y.C. Tai. (2001). "BrF ₃ Dry Release Technologies for Large Freestanding Parylene MEMS." International Conference on Solid-State Sensors and Actuators (Transducers '01). pg. 652-655.	

Examiner Signature	<i>Noori</i>	Date Considered	5/4/05
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.